

Notice of References Cited	Application/Control No. 09/820,695	Applicant(s)/Patent Under Reexamination LI ET AL.	
	Examiner Allan Olsen	Art Unit 1763	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
	C	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
*	U	Koshiishi et al., "Effect of Increasing the Upper Frequency on Dual Frequency Capacitive-Coupled-Plasma", Proceedings of Symposium on Dry Process, The Institute of Electrical Engineers of Japan, Nov. 11-13, 1998, pp 229-234.
	V	"After Moore's Law, Why Multiple Processors Matter", MacMusings by Dan Knight, (November 02, 1999) (http://www.lowendmac.com/musings/moore.shtml)
	W	"Intel, IBM put chip development in fast lane", by Michael Kanellios (Dec. 10, 2000), (http://news.com.com/Intel%2C+IBM+put+chip+development+in+fast+lane/2100-1001_3-249656.html)
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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